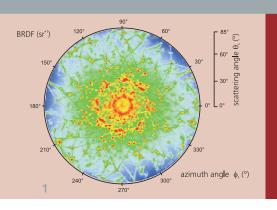
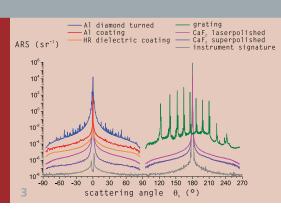


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- 1 3D reflectance and scattering distribution of a gemstone with facets.
- 2 Measurement system ALBATROSS-TT.
- 3 Examples of angle resolved scattering (ARS) measurements (azimuth angle 0°) in reflection and transmission hemispheres.

# ALBATROSS-TT TABLE-TOP SYSTEM FOR LIGHT SCATTER MEASUREMENT

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## **System description**

The new table top system ALBATROSS-TT (3D-Arrangement for Laser Based Transmittance, Reflectance and Optical Scatter measurement – Table Top) enables high sensitive measurements of angle resolved light scattering, reflectance and transmittance of optical and non-optical surfaces, materials and components within the entire 3D-sphere.

### **Applications**

Characterization of surfaces, coatings, and materials:

- Quality control, appearance
- Optical performance
- Roughness analysis

# **Specifications**

- Measurement of light scattering (ARS, BRDF, BTDF, scatter loss),  $\theta$ -2 $\theta$ , R and T
- Full 3D-spherical measurement capability
- In- and out-of-plane mode
- Flexible variation of incident angle, scattering angle (azimuth and polar angles), and polarization
- Area raster scans of sample surface
- Housed table top system ( $< 1 \text{ m}^3$ )
- Dynamic range: 13 orders of magnitude
- Backround ARS: 3x10<sup>-08</sup> sr<sup>-1</sup>
- Roughness equivalent sensitivity: < 0.1 nm
- Wavelengths: 405 nm, 532 nm, and 640 nm (other wavelengths on demand)
- User-friendly software for measurement control and data analysis
- Analysis tools: roughness, PSD, etc.